**P**CKET NO: 251891US0

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

APPLICATION OF

FUJIO SAKURAI, ET AL. : EXAMINER: WOLLSCHLAGER, J.

SERIAL NO: 10/822,815 :

FILED: APRIL 13, 2004 : GROUP ART UNIT: 1732

FOR: POLISHING PAD AND

PRODUCTION METHOD THEREOF

## RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the restriction requirement dated September 11, 2006, Applicants provisionally elect with traverse the invention of Group II, Claims 7-9.

Remarks/Arguments begin on page 2 of this paper.